

INFORMATION CITED BY APPLICANT THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION

Applicant: J. Taniguchi Attorney Docket No. NAII124945
Title: SURFACE PROCESSING METHOD

FOREIGN PATENT DOCUMENTS

*Examiner Initial	Cite No.	Document No.	Kind Code	Publication Date (mm/dd/yyyy)	Country	English Abstract Provided	Translation Provided
_____	F1	60-263145	A	12/26/1985	JP	X	
_____	F2	62-109049	A	05/20/1987	JP	X	
_____	F3	6-196086	A	07/15/1994	JP	X	X
_____	F4	7-219228	A	08/18/1995	JP	X	X
_____	F5	2002-192500	A	07/10/2002	JP	X	X
_____	F6	2002-196494	A	07/12/2002	JP	X	X

Examiner

Date Considered

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